

Form PTO-1449

DocId (Number) (Optional)

Application Number

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Applicant

J. Chen

Filing Date

01/08/01

Group Art Unit

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILED DATE IF APPROPRIATE
JMM	5 700 735	12/23/97	Shine et al.	438	612	8/22/96
	5 707 894	1/13/98	Hsiao	437	209	10/27/95
	5 807 787	9/15/98	Fu et al.	438	623	12/2/96
	5 834 365	11/10/98	Ming-Tsung et al.	438	612	8/25/97
	5 309 025	5/3/94	Bryant et al.	257	784	7/27/92
	5 904 565	5/18/99	Nguyen et al.	438	687	7/17/97
	5 795 796	8/18/98	Kim	437	189	4/18/96
	5 668 411	9/16/97	Hong et al.	257	751	7/23/96
	5 785 236	7/28/98	Cheung et al.	228	180.5	11/29/95
	5 547 901	8/20/96	Kim et al.	437	187	5/19/95
	5 631 498	5/20/97	Anschel et al.	257	690	5/19/95

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
					YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Portlnox Pages, Etc.)

EXAMINER

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